



PATENT



IN THE UNITED STATES PATENT
AND TRADEMARK OFFICE

Applicant: Won Kwon Lee

Serial No.: 10/622,532

Filed: July 18, 2003

For: METHOD FOR FORMING
ISOLATION FILMS IN
SEMICONDUCTOR DEVICES

Group Art Unit: 1765

Examiner: DuyVu n. Deo

I hereby certify that this paper (or fee) is being deposited with the United States Postal Service, first class postage prepaid, addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 :

September 14, 2005

James P. Zeller
Reg. No. 28,491

AMENDMENT "A"

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Please amend the above-identified application as follows:

the amendments to the claims section begins on page 2 of this paper; and
the remarks begins on page 7 of this paper.